

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Michio NEMOTO et al.

Serial No.: 10/083,673

Filed: February 25, 2002



Group Art Unit: 2815

Examiner:

For: SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE SAME

Certificate of Mailing

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By:

Marc A. Rossi

INFORMATION DISCLOSURE STATEMENT

Assistant Commissioner for Patents
Washington, D.C. 20231

Sir:

Pursuant to 37 C.F.R. §1.56, the attention of the Patent and Trademark Office is hereby directed to the reference listed on the attached Form PTO-1449. A copy of the reference listed on Form PTO-1449 is attached.

It is respectfully requested that the information be expressly considered during the prosecution of this application, that this reference be made of record therein and appear among the references cited on any patent to issue therefrom, and that an initialed copy of the PTO-1449 be returned to the undersigned.

Respectfully submitted,

Date:

05/24/02

Marc A. Rossi

Registration No. 31,923

Attorney Docket No.: FUJI:212

